

Notice of References Cited	Application/Control No. 10/589,802		Applicant(s)/Patent Under Reexamination KOBAYASHI ET AL.	
	Examiner Vivian Chen		Art Unit 1794	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-7,026,064	04-2006	Tsunekawa et al.	428/847.4
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	O	JP 02-143836	06-1990	JP	Abe et al.	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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